

KLA Tencor INSPEX EAGLE

Patterned Wafer Laser Inspection sn 008009E24

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Patterned Wafer Laser Inspection

Wafer Size: 150mm capable 4" up to 8"

Equipment Details:

Wafer inspection system

Chuck, 6"

Prealigner, 6"

Cassette to cassette handling

(2) Ports

ZEISS Microscope

Including manuals



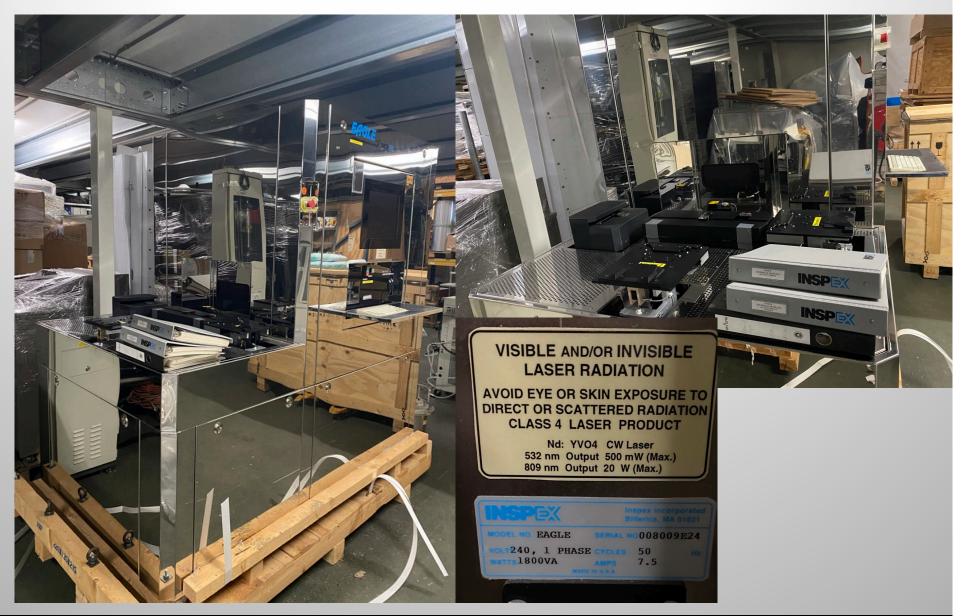


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Refurbishment

From custom to complete refurbishment

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Materials

Supplier of first class second source materials

